

Docket No.: 2336-229



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : U.S. PATENT No. 6,893,889

Young Ho PARK *et al.* : Confirmation No. 2726

U.S. Patent Application No. 10/735,615 : Group Art Unit: 2829

Filed: December 16, 2003 : Issued: May 17, 2005

: Examiner: Asok Sarkar

For: METHOD FOR MANUFACTURING GALLIUM NITRIDE-BASED
SEMICONDUCTOR LIGHT EMITTING DEVICE

CITATION OF PRIOR ART IN PATENT FILE UNDER 37 C.F.R. 1.501

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


Sir:

Submitted concurrently herewith are copies of references cited in a Japanese Office Action in connection with the corresponding Japanese application.

Applicants are submitting references after the grant of a patent to be placed in the file but not considered by the Patent Office. Thus, no certification or fees are deemed necessary.

Respectfully submitted,

LOWE HAUPTMAN & BERNER, LLP


Benjamin J. Hauptman
Registration No. 29,310

1700 Diagonal Road, Suite 310
Alexandria, Virginia 22314
(703) 684-1111 BJH/klb
Facsimile: (703) 518-5499
Date: May 20, 2005